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This is a request for filing a U.S. Patent Application claiming priority, under 35 U.S.C. §120, from US Application 09/665,544, filed on September 19, 2001.

Pages

Applicant:

James W. Overbeck

Title:

WIDE FIELD OF VIEW AND HIGH SPEED SCANNING MICROSCOPY

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This application is a continuation (and claims priority under 35 U.S.C. §120) of US Application 09/665,544, filed on September 19, 2001, which is a continuation of PCT Application PCT/US99/06097 filed on March 19, 1999; a continuation-in-part of US Application Ser. No. 09/170,847, filed on October 13, 1998; and a continuation-in-part of US Application Ser. No. 09/045,547, filed on March 20, 1998. The disclosure of the above-mentioned applications is considered part of, and is incorporated by reference in, the disclosure of this application.

Kindly acknowledge receipt of this application by returning the enclosed postcard.

Respectfully submitted,

Ivan D. Zitkovsky, Reg. No. 37, 482